

Form PTO-1449  
(Rev. 8-83)U.S. Department of Commerce  
Patent and Trademark Office

Attorney Docket No: 740756-2378

Serial No. Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT**

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI et al.

Filing Date: November 8, 2001

Group: 2812

**U.S. PATENT DOCUMENTS**

| Examiner Initial | Document Number | Date       | Name              | Class | Subclass | Filing Date (if appropriate) |
|------------------|-----------------|------------|-------------------|-------|----------|------------------------------|
| ✓                | 5,612,250       | 03/18/1997 | Ohtani et al.     |       |          |                              |
| ✓                | 5,543,352       | 08/06/1996 | Ohtani et al.     |       |          |                              |
| ✓                | 5,895,933       | 04/20/1999 | Zhang et al.      |       |          |                              |
| ✓                | 5,882,960       | 03/16/1999 | Zhang et al.      |       |          |                              |
| ✓                | 6,051,453       | 04/18/2000 | Takemura          |       |          |                              |
| ✓                | 5,953,597       | 09/14/1999 | Kusumoto et al.   |       |          |                              |
| ✓                | 5,561,081       | 10/01/1996 | Takenouchi et al. |       |          |                              |
| ✓                | 5,897,799       | 04/27/1999 | Yamazaki et al.   |       |          |                              |
| ✓                | 6,002,101       | 12/14/1999 | Yamazaki et al.   |       |          |                              |
| ✓                | 5,968,383       | 10/19/1999 | Yamazaki et al.   |       |          |                              |
| ✓                | 5,900,980       | 05/04/1999 | Yamazaki et al.   |       |          |                              |
| ✓                | 6,038,075       | 03/14/2000 | Yamazaki et al.   |       |          |                              |
| ✓                | 5,959,779       | 09/28/1999 | Yamazaki et al.   |       |          |                              |
| ✓                | 4,599,133       | 07/08/1986 | Miyao et al.      |       |          |                              |
| ✓                | 6,002,523       | 12/14/1999 | Tanaka            |       |          |                              |
| ✓                | 4,609,407       | 09/02/1986 | Masao et al.      |       |          |                              |
| ✓                | 5,972,742       | 10/26/1999 | Zhang et al.      |       |          |                              |
| ✓                | 5,643,801       | 07/01/1997 | Ishihara et al.   |       |          |                              |
| ✓                | 5,612,251       | 03/18/1997 | Lee               |       |          |                              |
| ✓                | 6,088,379       | 07/11/2000 | Owa et al.        |       |          |                              |
| ✓                | 5,432,122       | 07/11/1995 | Chae              |       |          |                              |

**FOREIGN PATENT DOCUMENTS**

| Document Number | Date       | Country | Class | Subclass | Translation<br>Yes No |
|-----------------|------------|---------|-------|----------|-----------------------|
| ✓ 07-161634     | 06/23/1995 | Japan   |       |          | Abstract              |
| ✓ 07-321339     | 12/08/1995 | Japan   |       |          | Abstract              |
| ✓ 07-131034     | 05/19/1995 | Japan   |       |          | Abstract              |
| ✓ 56-064480     | 06/01/1981 | Japan   |       |          | Abstract              |
| ✓ 09-260676     | 10/03/1997 | Japan   |       |          | Abstract              |

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

|          |   |
|----------|---|
| ✓        | Specification and Drawings for Patent Application Serial No. 09/610,637, "Laser Irradiation Apparatus, Laser Irradiation Method, Semiconductor Device, and Method of Manufacturing a Semiconductor Device". |
| ✓        | Y. Helen et al. "Reproducible High Field Effect Mobility Polysilicon Thin Film Transistors Involving Pulsed Nd:YVO <sub>4</sub> Laser Crystallization" IEEE IDM 99, p. 297.                                 |
| Examiner | Date Considered 12/11/01  |

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.